

|           |       |          |
|-----------|-------|----------|
| FIG.      |       |          |
| BY        | CLASS | SUBCLASS |
| DRAFTSMAN |       |          |

Title: WAFER HEAT-TREATMENT  
SYSTEM AND WAFER  
HEAT-TREATMENT METHOD  
Inventor(s): Yoshimasa KAWASE  
DOCKET NO.: 025311-0115

5700  
1-3

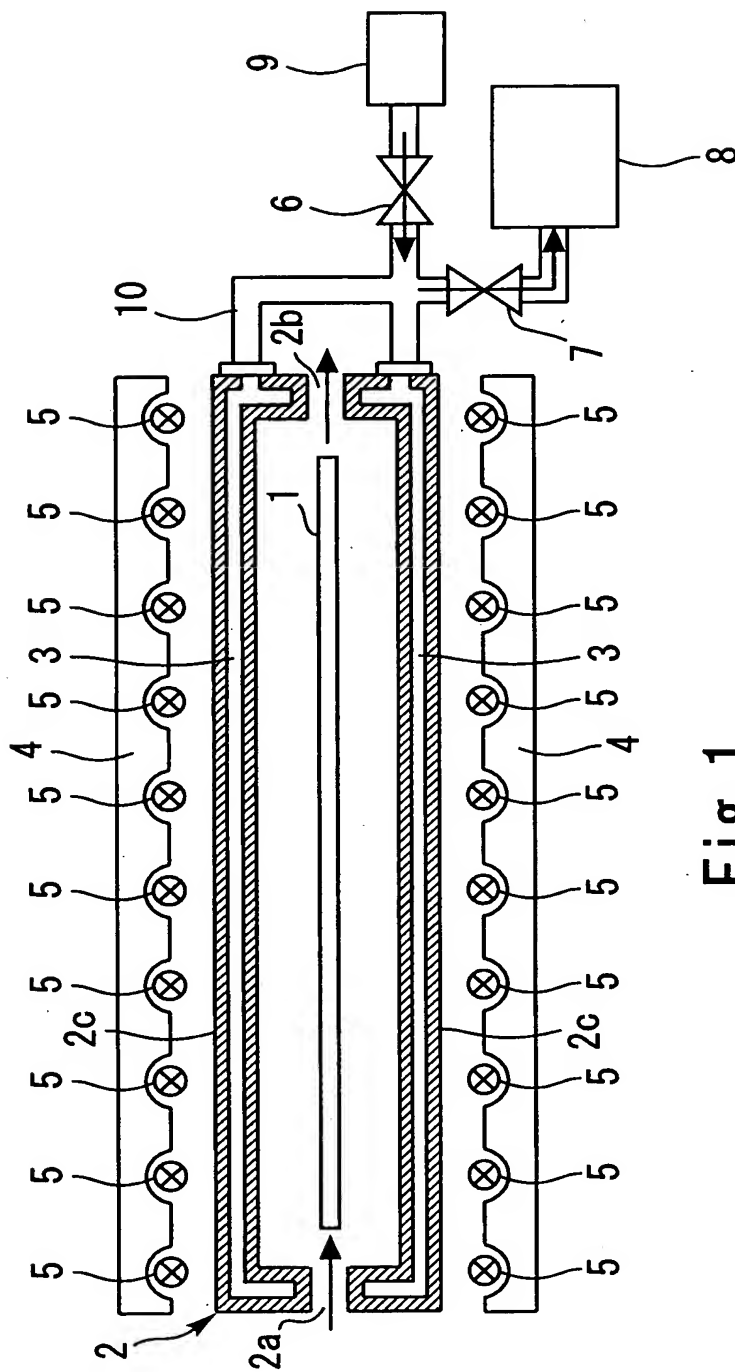
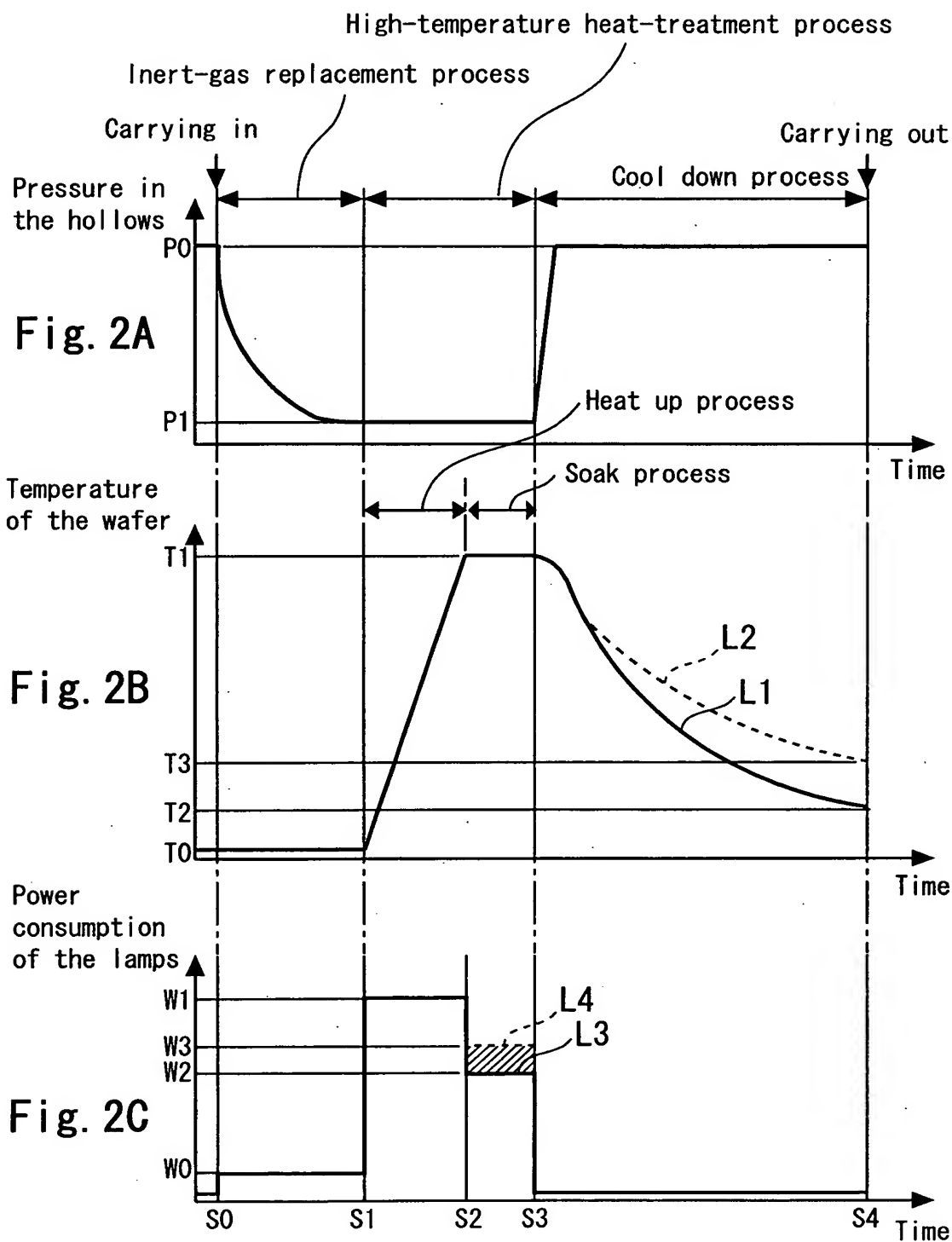


Fig. 1

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432  
81



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# PRIOR ART

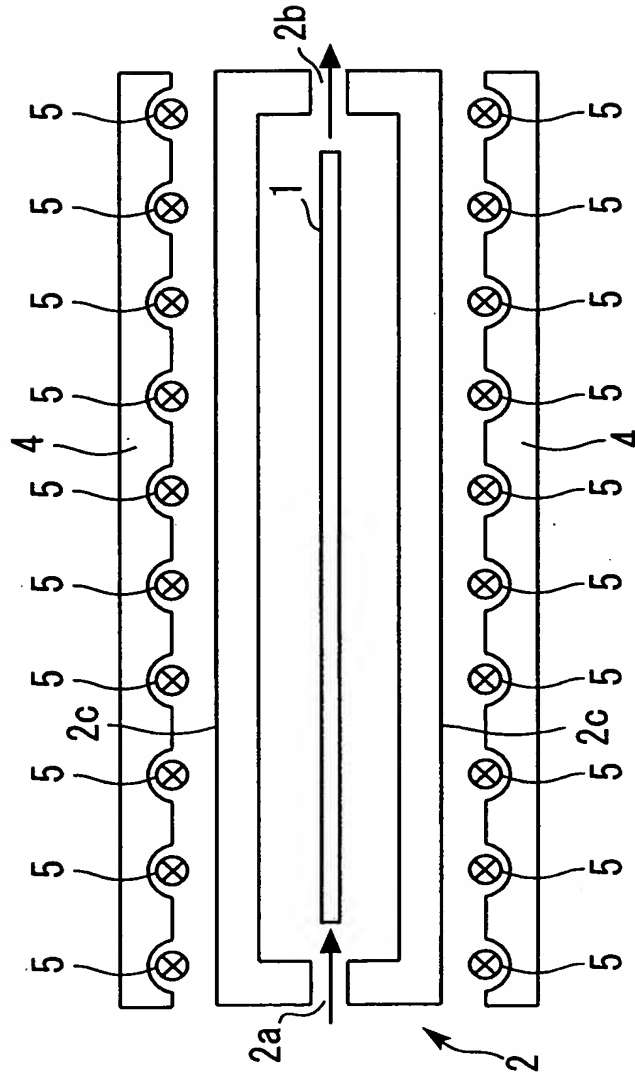


Fig. 3